

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re:	Application No. 10/577,069)	
)	
Filed:	June 20, 2006)	Confirmation No. 4111
)	
Applicants:	Masahiko HATA et al.)	
)	
Title:	METHOD FOR MANUFACTURING COMPOUND SEMICONDUCTOR SUBSTRATE)	This Amendment was electronically filed on March 9, 2010 using EFS-Web.
)	
Art Unit:	2891)	
)	
Examiner:	Julia SLUTSKER)	
)	
)	
Attorney Docket:	7372/88130)	
)	
Customer No.:	42798)	

Mail Stop AMENDMENT
Commissioner for Patents
P. O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

Sir:

Applicants hereby petition under 37 CFR § 1.136(a) for a two-month extension of time in the above-captioned application, up to and including March 20, 2010, to make this reply timely.

In response to the Office Action mailed October 20, 2009, Applicants respectfully submit the following:

Amendments to the Claims reflected in the listing of claims beginning on page 2 of this paper;

Remarks beginning on page 5 of this paper; and